



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re U.S. Patent Application of

MIGITAKA et al.

Application Number: 10/020,904

Filed: December 19, 2001

For: PHOTOMASK AND MANUFACTURING METHOD  
OF AN ELECTRONIC DEVICE THEREWITH

ATTORNEY DOCKET NO. HITA-0136

Unit 1756

Examiner  
Barreca, Nicole

Honorable Assistant Commissioner  
for Patents  
Washington, D.C. 20231

**COVER LETTER**

Sir:

[ x ] The fee for submission of claims is calculated as shown below:

FOR	TOTAL WITH NEW CLAIMS ADDED	TOTAL CURRENTLY ON FILE	CLAIMS PAID	RATE	CALCULATION
Total Claims	20	20	(Over 20)	x \$18	0
Independent Claims	5	5	2 (Over 3)	x \$86	0
MULTIPLE DEPENDENT CLAIM(S)				+ \$290	0
REDUCTION FOR FILING BY SMALL ENTITY (note 37 C.F.R. §§ 1.9, 1.27, 1.28). IF APPLICABLE, VERIFIED STATEMENT MUST BE ATTACHED				x ½	
			TOTAL		0

In addition, the below-identified communications are submitted in the above-captioned application or proceeding:

[ x ] Response to Office Action  
(with Claim Amendments)

[ ] Preliminary Amendment

[ ] Substitute Specification

[ ] Other \_\_\_\_\_

[ x ] Petition for Extension of Time 1 month

[ ] Terminal Disclaimer

[ ] Letter to Draftsperson

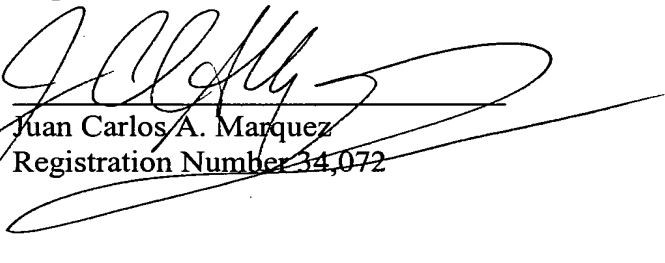
[ ] \_\_\_\_\_ sheets of drawings

[ ] Petition under \_\_\_\_\_

- [ ] Please charge my **Deposit Account Number** \_\_\_\_\_ in the amount of \_\_\_\_\_ to cover the fees for \_\_\_\_\_. A duplicate copy of this paper is enclosed.
- [x] A check in the amount of \$ **110.00** to cover the one-month extension fee is enclosed.
- [x] The Commissioner is hereby authorized to charge any additional fees associated with this communication, or credit any overpayment to **Deposit Account Number 08-1480**.

Respectfully submitted,

\_\_\_\_\_  
Stanley P. Fisher  
Registration Number 24,344

  
\_\_\_\_\_  
Juan Carlos A. Marquez  
Registration Number 34,072

**REED SMITH LLP**  
3110 Fairview Park Drive, Suite 1400  
Falls Church, Virginia 22042  
(703) 641-4200  
**March 12, 2004**

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**RESPONSE AND AMENDMENT UNDER 37 C.F.R. §1.111**

**Sir:**

This is in response to the office action dated December 11, 2003, in the above identified application, the period for response which is set to expire on April 11, 2004, with the one-month extension fee submitted herewith. Please amend the above identified application as follows: